

**ELECTRONIC INFORMATION DISCLOSURE STATEMENT**

Electronic Version v18  
 Stylesheet Version v18.0

Title of  
 Invention

**PHYSICAL VAPOR DEPOSITION APPARATUS AND  
 PROCESS**

Application Number: 10/063808  
 Confirmation Number: 4319  
 First Named Applicant: Ramgopal Darolia  
 Attorney Docket Number: 13DV-13711  
 Art Unit: 1753  
 Examiner: Mr. Steven H. VerSteeg  
 Search string: ( 6007880 ).pn.



**US Patent Documents**

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

Init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	6607680	1999-12-28	Maloney		427	585

Signature

Examiner Name	Date
	Dec 1, 2004

INFORMATION DISCLOSURE  
CITATION IN AN APPLICATIONAttorney Docket No.  
13DV-13711Application No.  
10/063,808

Submitted by:

*Domenica N.S. Hartman*

Applicant:

Ramgopal Darolia, et al

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Filing Date:  
05/15/03Group Art No.  
1753

## U.S. PATENT DOCUMENTS

Examiner's Initials	Document Number	Date	Name	Class	Subclass	Filing Date if appropriate
	4,403,002	09/06/83	Akashi, et al	427	255.5	
	5,296,374	03/22/94	Morchen, et al	427	566	

RECEIVED  
SEP 10 2003  
TC 1700

## FOREIGN PATENT DOCUMENTS

Examiner's Initials	Document Number	Date	Country	Class	Subclass	Translation Yes   No
SHV	JP05156438	06/22/93	Japan	C42C	14/54	
SHV	JP06322521	11/22/94	Japan	C42C	14/56	
	EP1008669	06/14/00	Europe			

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

Examiner	Date Considered
<i>[Signature]</i>	<i>June 1, 2003</i>

\*Examiner: Initial if reference considered whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.